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, .1, .35, : 119991, -1, ,
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501.001.70

- ,
.. .

(nc-Si),

nc-Si

nc-Si

Si,

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1956 .

A. Uhlir.

(1000 ²/)

nc-Si,

(-), ,

2002

(¹ ₂,

2S+1).

¹ ₂

(³ ₂).

() ,
1 2 nc-Si.

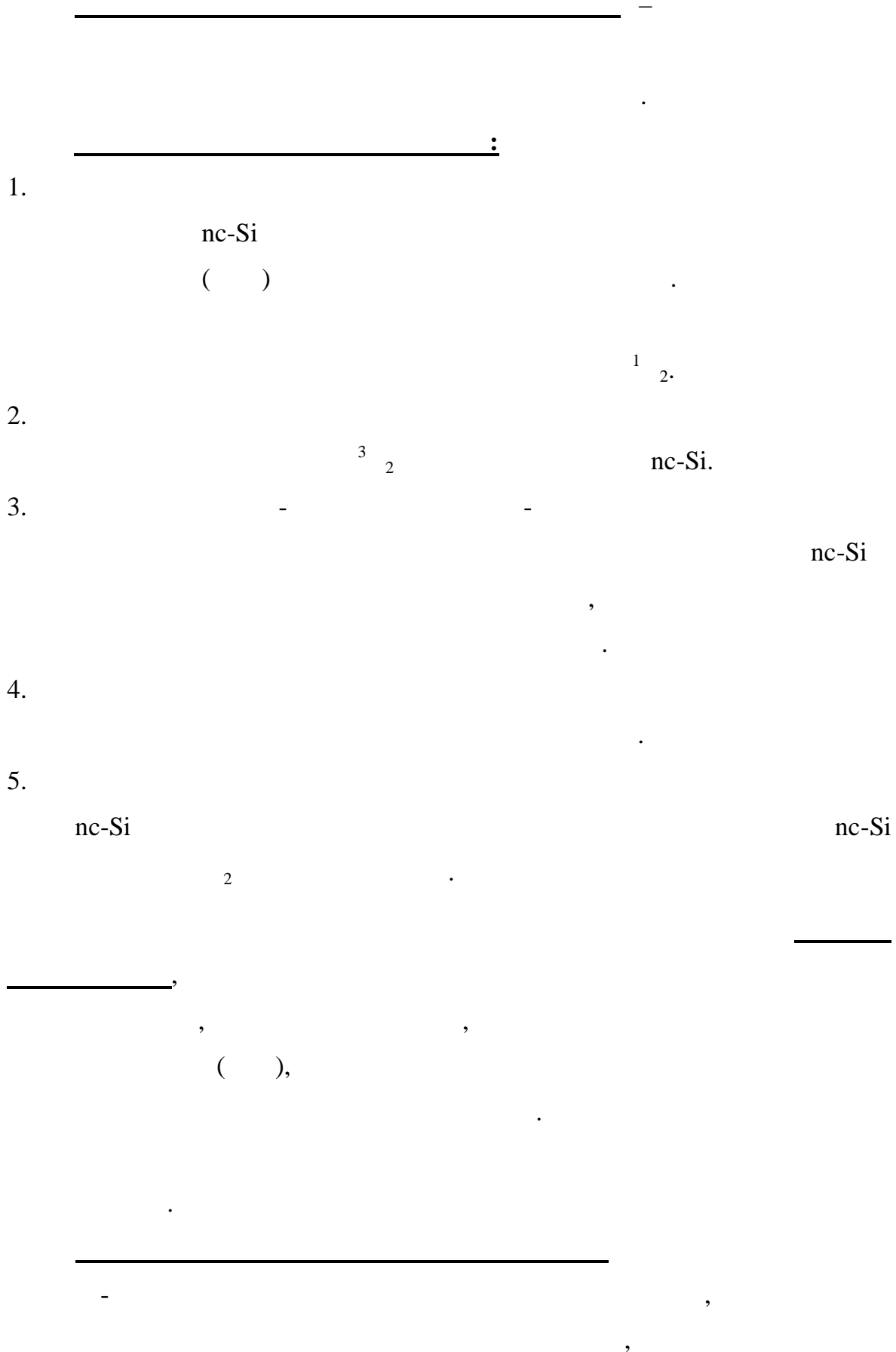
,
() - ,
1 2 nc-Si

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nc-Si 1 2,

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nc-Si .

nc-Si,



nc-Si.

1.  .
(-)
2. .
nc-
3. Si ,
1 2.
nc-Si.
4. 3 2
nc-Si.
5. nc-Si.
-
6. nc-Si ,
- .
1.  ,
- ,
-

2.

3.

4.

5.

6.

30 %

3 2

nc-Si

1 2



nc-Si

(nc-Si)

nc-Si

[1-14]

: 6-th International Conference on Porous Semiconductors – Science and Technology (PSST-2008), Sa-Coma (Mallorca), Spain, 2008; 5-th International Conference on Porous Semiconductors – Science and Technology (PSST-2006), Sitges-Barcelona, Spain, 2006; 21-th International Conference «Amorphous and microcrystalline semiconductors», Lisbon, Portugal, 2005; Sensors for Environment, Health and Security: Advanced Materials and Technologies, Vichy, France, 2007; VIII

« -2007», 2007;
« -2008», 2008; « -2006»,
« », 2006; « -2005», « », 2005;
VI «
», - , 2008.

2.1

() p-
HF (48%) C₂H₅OH (98%) 1:1.

~50 .

() 1 20
nc-Si 1 5 , 1 2.

– () ().

(- , 0,01
0,02 .) nc-Si 10 50 ,
1 2 . 1
,

2.2

BRUKER ELEXSYS 580
(9.5 - X- , 5·10¹⁰ / ;
35 - Q- , 5·10⁹ /).

~1 .

1

c-Si	-	-	/ ²	, %	-	
p	(100)	1...10	55	70	~500	I
					0.01 – 5	I
		70	85	~10 ³	II	
				0.01 – 5	II	
		10...20	50	65	~500	III
		0.01...0.02	50	55	~500	IV
	(110)	0.01...0.02	50	60	~500	V

I – III

IV

V –

2.3

$$E_{exc} = 3.7 \quad (\lambda = 337 \text{ nm}),$$

10

5-54

($\nu = 100$).

3.1

Si / SiO₂)

(P_{b^-} -

nc-Si,

(<2%)

nc-Si.

nc-Si.

3.2

1

($P_{mw} = 200$). $P_{mw} = 200$

P_{b^-}

³₂,

1 ,

:

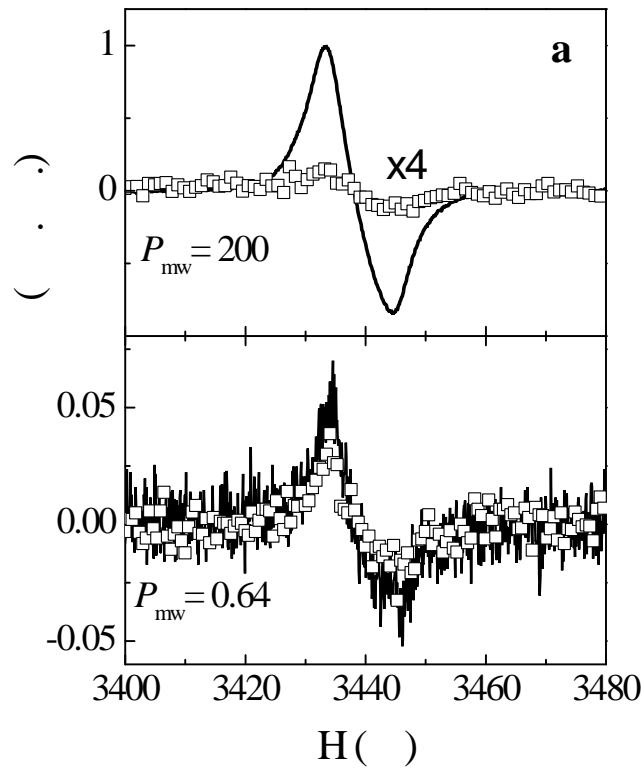
2

(1 , $P_{mw} = 0.64$)

P_{b^-}

« »

/ (1).



.1 (p
 = 1) (p = 10⁻⁴ , (a)
 0,64 (). 200

kT.

1,63 (±

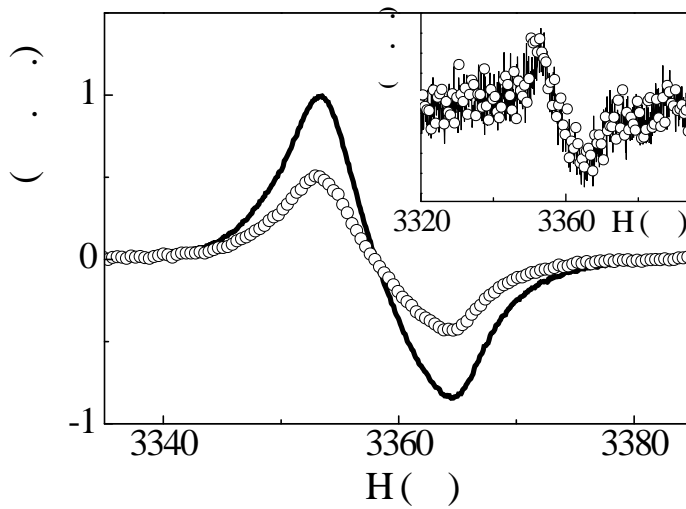
~63 Δ

)

³₂

(P_{b^-}).

(2).



.2

() () ().

$650 / ^2; P_{mw} = 200$
1 .

(1).

P_{mw} ,

$$I_{\text{EPR}}(\sqrt{P_{\text{mw}}}) \quad (3).$$

$$I_{\text{EPR}} = \frac{a\sqrt{P_{\text{mw}}}}{(1 + bP_{\text{mw}})^{3/2}}, \quad (1)$$

$$I_{\text{EPR}}(\sqrt{P_{\text{mw}}}) \quad I_{\text{EPR}}(\sqrt{P_{\text{mw}}})$$

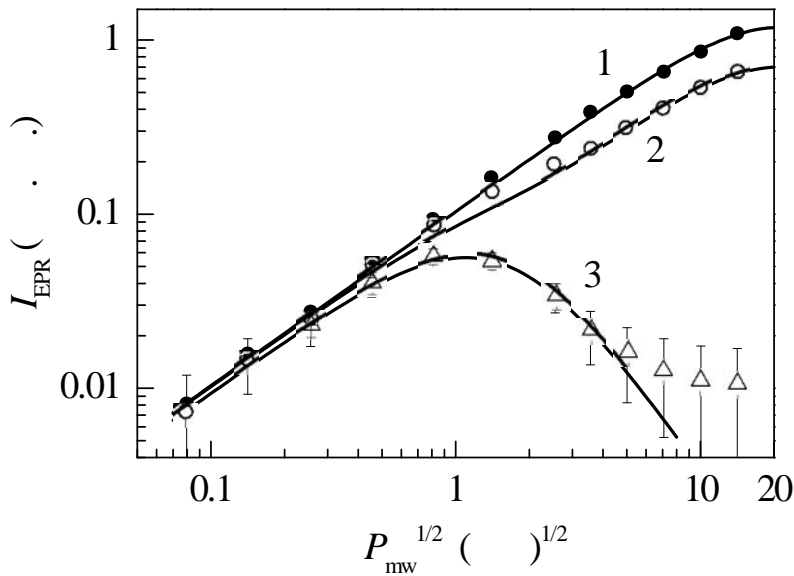
$$(3):$$

$$I_{\text{EPR}}^{\text{light}} = \alpha \cdot I_{\text{EPR}}^{\text{vac}} + \beta \cdot I_{\text{EPR}}^{\text{dark}}.$$

α

(< 4),

β -



.3

($p =$ (1))

(2) ($p = 10^{-4}$)

(3). (1) (2)

$P_{\text{mw}} \geq 1$

(> 4),

($\alpha + \beta = 1$).

α

$$\alpha = \frac{I_{\text{EPR}}^{\text{dark}} - I_{\text{EPR}}^{\text{light}}}{I_{\text{EPR}}^{\text{dark}} - I_{\text{EPR}}^{\text{vac}}} \quad (2)$$

α ,

(2)

P_{mw} ,

3.2

(Q-)

(~40 %)

30 %

3.3

T_2

2,

2

()

-	1	22.4 ± 1.6	10.5 ± 0.7	13.8 ± 1.0
	2	7.7 ± 0.5	4.6 ± 0.3	6.1 ± 0.4
-	1	17.2 ± 1.2	11.1 ± 0.8	11.4 ± 0.8
	2	4.3 ± 0.3	3.4 ± 0.2	3.4 ± 0.2
c-Si	1	4.5 ± 0.3		

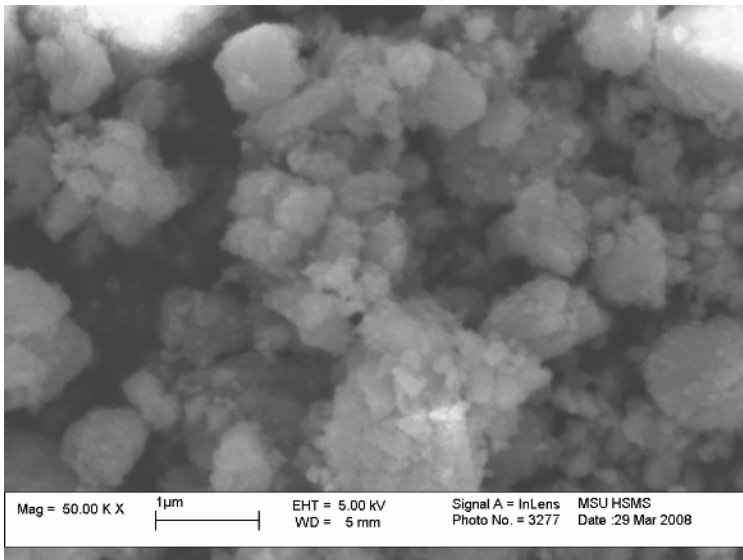
P_b^-

4.1

(

(4),

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.4
 ,
 50000 .

P_b-

2 .

4.2

1
 2,

(5).

3.1

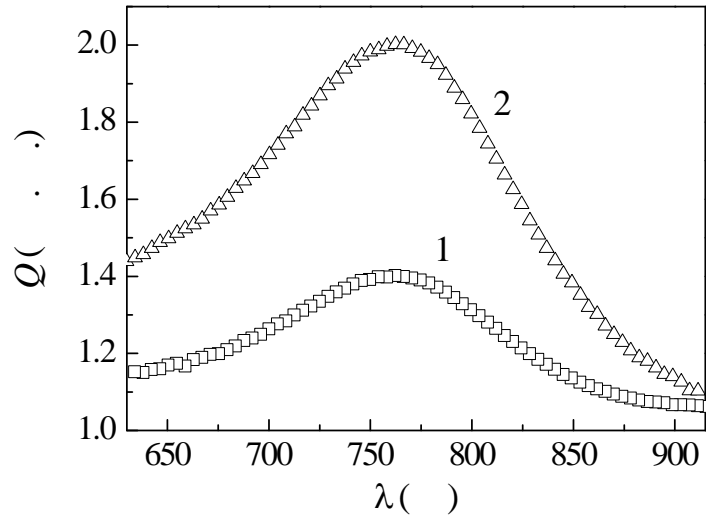
Si.

nc-Si

(

).

1 2



.5

(1)

(2)

nc-Si

nc-Si

4.3

P_b^-

P_b^-

1 2

4.4

nc-Si

»,
 ,
 . «
 » ,
 nc-Si ,
 :

$$\frac{dN_1}{dt} = -\alpha N_1 - 2DN_1^2, \quad (3)$$

$$\alpha \equiv \alpha_r + DN',$$

$$N_1 - \text{nc-Si} (\quad),$$

$$N' - \text{nc-Si} , \quad \alpha_r -$$

$$, D -$$

(3)

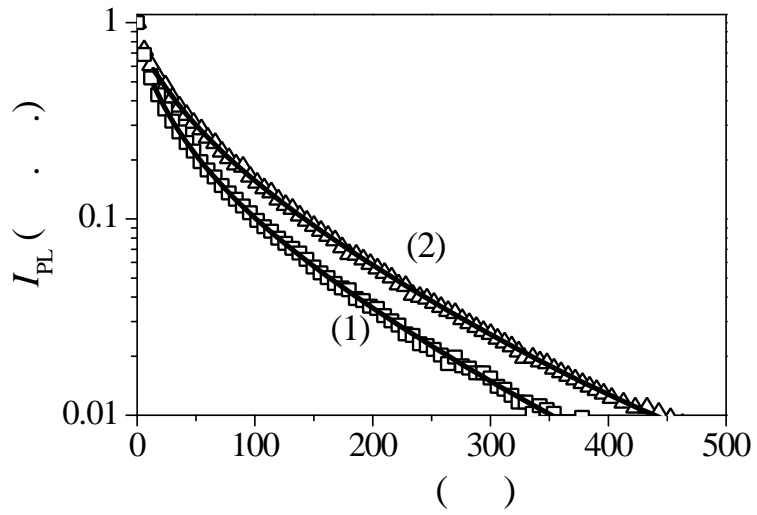
$$N_1(t) = \frac{\alpha N_1^{(0)}}{\alpha \exp(\alpha t) + 2DN_1^{(0)}(\exp(\alpha t) - 1)}, \quad (4)$$

$$N_1(t=0) = N_1^{(0)} - \quad . \quad (4)$$

(6,);
 (4) « » ,

4.5

1 2,



.6

(1) 70%
 $p = 1$, $\lambda = 760$

nc-Si

SiO₂,

nc-Si.

1.

2.

3.

30 %

3 2

4.

5.

nc-Si

¹ ₂
nc-Si

1.

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2008. - . 27. - 10. - . 90-94.

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 // . – 2007. – . 85. – 1. – . 65-68.
4. Konstantinova, E.A. Electron-paramagnetic resonance and photoluminescence study of Si nanocrystals-photosensitizers of singlet oxygen molecules / E.A. Konstantinova, V.A. Demin, A.S. Vorontsov, Yu.V. Ryabchikov, I.A. Belogorohov, L.A. Osminkina, P.A. Forsh, P.K. Kashkarov, V.Yu. Timoshenko // J. Non-Cryst. Sol. – 2006. – V. 352. – 8. – P. 1156-1159.
 5. Konstantinova, E.A. EPR diagnostics of singlet oxygen generation on porous silicon surface / E.A. Konstantinova, V.A. Demin, M.B. Gongalskiy, Yu.V. Ryabchikov, P.K. Kashkarov // Materials of 6-th International Conference PSST-2008, Sa-Coma (Mallorca), Spain, 2008, March, 10-14. – Sa-Coma (Mallorca), 2008. – P. 375-376.
 6. Konstantinova, E.A. EPR study of silicon nanocrystals-photosensitizers of singlet oxygen molecules / E.A. Konstantinova, V.A. Demin, P.A. Forsh, V.Yu. Timoshenko, P.K. Kashkarov, K. Lips // Materials of 5-th International Conference PSST-2006, Barselona-Sitges, Spain, 2006, March, 12-17. – Barselona-Sitges, 2006. – P. 410-411.
 7. Ryabchikov, Yu.V. Photoluminescence and EPR investigation of silicon nanocrystals as photosensitizers of singlet oxygen molecules / Yu.V. Ryabchikov, A.S. Vorontsov, I.A. Belogorokhov, V.A. Demin, L.A. Osminkina, E.A. Konstsntinova, P.A. Forsh, P.K. Kashksrov, V.Yu. Timoshenko // 21-st International Conference on «Amorphous and Nanocrystalline Semiconductors» : Book of Abstracts, Lisbon, Portugal, 2005. – Lisbon, 2005. – P. 380.
 8. Vorontsov, A.S. Optical Spectroscopy of Silicon Nanocrystals for Biomedical Applications / A.S. Vorontsov, V.A. Demin, Yu.V. Ryabchikov, V.Yu. Timoshenko, P.K. Kashkarov // Sensors for Environment, Health and

Security: Advanced Materials and Technologies, Vichy, France, 2007. – Vichy, 2007. – P. 116.

9. , . . . / . . .
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// VIII

« -2007», , 2007.– , 2007. – . 102.

10. , . . . / . . . , . . . //
-2008, :
, , 16-25 2008. – . : - . . . ,
2008. – . 94-97.

11. , . . . / . . . // -2006. « » :
, . 2, , 2006. – . : - . . . , 2006.
– . 63-65.

12. , . . . / . . . // -2005.
« » : , . 2, , 2005. – . : -
. . . , 2005. – . 61-63.

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, . . . , . . . //
: VI

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